

APPLICATION DATA SHEET**Application Information**

Application type:: Regular
Subject matter:: Utility
CD-ROM or CD-R?:: None
Title:: PHOTORESIST BASE MATERIAL, METHOD
FOR PURIFICATION THEREOF, AND
PHOTORESIST COMPOSITION
Attorney Docket Number:: 28955.1048
Request for Early Publication:: No
Request for Non-Publication:: No
Total Drawing Sheets::
Small Entity?:: No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full capacity
Given Name:: Mitsuru
Middle Name::
Family Name:: Ueda
City of Residence:: Meguro-ku
State or Province of Residence:: Tokyo
Country of Residence:: Japan
Street of Mailing address:: c/o Tokyo Institute of Technology
2-12-1, Ookayama
City of Mailing Address:: Meguro-ku
State of Mailing Address:: Tokyo
Country of Mailing Address:: Japan
Postal or Zip Code of mailing address:: 152-8550

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full capacity
Given Name:: Hirotoshi
Middle Name::
Family Name:: Ishii
City of Residence:: Ichihara-shi
State or Province of Residence:: Chiba
Street of mailing address:: 1-1, Anesakikaigan
City of mailing address:: Ichihara-shi
State or Province of mailing address:: Chiba
Country of Mailing Address:: Japan
Postal or Zip Code of mailing address:: 299-0193

Correspondence Information

Correspondence Customer Number:: 27890

Representative Information

Representative Customer Number:: 27890

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	National Stage of	PCT/JP2003/011137	09/01/03

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-300144	10/15/02	Yes
Japan	2003-112458	04/17/03	Yes